

IN THE SPECIFICATION:

At page 1, please replace paragraph [0001] inserted by the substitute specification filed on October 1, 2001, with the following replacement paragraph. A marked-up version of paragraph [0001], showing the changes made thereto, is attached.

B1
--This application is a division of U.S. Application No. 08/794,891, filed February 5, 1997, now U.S. Patent 6,309,691 B1, issued October 30, 2001.--

Please replace paragraph [0068] with the following replacement paragraph. A marked-up version of paragraph [0068], showing the changes made thereto, is attached.

B2
--[0068] With a second technique for removing defective precursor films, after diluting the film with a solvent as with the above-described first technique (FIG. 2A), the solvent is sucked and removed from the film. The operation of sucking the solvent can be carried out by means of a spongy piece of porous resin 16 fitted to the front end of a rod 17 or alternatively by means of a syringe needle or a tube. The device shows the original profile as shown in FIG. 2C after removing the solution dissolving the precursor film so that another precursor film may be formed there. With this technique, electron-emitting devices may be arranged more densely than the case where the above-described first technique is used. In other words, this technique is suited in cases where the puddle of the solvent cannot be sufficiently expanded, and the first technique is not feasible.--
